

Application/Control No.	Applicant(s)/Patent under Reexamination				
10/684,737	KIM ET AL.				
Examiner	Art Unit				
Rip A. Lee	1713				

**EXMR** 

SEARCHED				-	SEARCH NOTES (INCLUDING SEARCH STRATEG)				
Class	Subclass	Date	Examiner			DATE			
525	342	07-19-200	C/L		EAST tot scorr	07-19-20	5		
524	492	07-19-200	SM	_	PALM involvesh	D7-18-20E	7		
523	351	07-19-100	m_						
423	332	87-19-25	57/		_				
					·				
			<u> </u>						
							$\vdash$		

				-	
	,				•
·		<u> </u>			

Class

Subclass

Date

Examiner